	L#	Hits	Search Text	DBs	Time Stamp
1	L1	44948	aluminosilicate or ((alumino or aluminum) adj (silicate silicon))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
2	L8	475	doped adj metal adj oxide	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
3	L29	0	(si silicon) adj (doped containing) adj (Al2O3 ("Al.sub.2" adj "O.sub.3"))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
4	L15	6	(si silicon) adj (doped containing) adj metal adj oxide	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
5	L22	1	(si silicon) adj (doped containing) adj aluminum adj oxide	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
6	L36	208	(si silicon)adj (Al2O3 ("Al.sub.2" adj "O.sub.3"))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
7	L43	1853	(si silicon) near15 (doped dopant containing) near15 (metal adj oxide)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
8	L50	958	(si silicon) near15 (doped dopant containing) near15 (Al2O3 ("Al.sub.2" adj "O.sub.3"))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
9	L57	2776	43 50	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
10	L64	12	50 same (gate adj (dielectric insulation insulating insulative insulator oxide))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
11	L71	59	43 same (gate adj (dielectric insulation insulating insulative insulator oxide))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
12	L78	9	5923056.URPN.	USPAT	2002/02/20 19:49
13	L79	26	71 and (aluminum or "Al.sub.2")	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
14	L86	24203	aluminosilicate or (alumino adj silicate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
15	L93	4	86 same (gate adj (dielectric insulation insulating insulative insulator oxide))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
16	L100	22704	(metal aluminum) adj silicate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
17	L107	20	100 same (gate adj (dielectric insulation insulating insulative insulator oxide))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
18	L114	416	(evaporat\$3 coevaporat\$3 sputter\$4 cosputter\$4) same ((silicon adj monoxide) or SiO) same (("Al.sub.2" adj "O.sub.3") or (aluminum adj oxide) or alumina or sapphaire)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	
19	L121	67	(evaporat\$3 coevaporat\$3 sputter\$4 cosputter\$4) same (silicon adj monoxide) same (("Al.sub.2" adj "O.sub.3") or (aluminum adj oxide) or alumina or sapphaire)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	20:22
20	L128	21	114 and (gate adj (dielectric insulation insulating insulative insulator oxide))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	: